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FROM :LØRUSSO & LOUD

FAX NO. :703 739 9391

Mar. 26 2002 10: 22AM P10

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIMOTO et al

Serial No.: 08/897,839

Filed: July 21, 1997

For: STRESS-ADJUSTED INSULATING
FILM FORMING METHOD,
SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING THE
SAME

SAME

## PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of June 19, 2001, initially set to expire September 19, 2001, be extended two months up to and including November 19, 2001. The requisite \$400.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to Deposit Account No. 12-2174.

Respectfully submitted

Reg. No. 25,814

Date: November 19, 2001

LORUSSO & LOUD 3137 Mount Vernon Avenuc Alexandria, VA 22305 (703) 739-9393